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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

TETSUO SUZUKI, ET AL.

: EXAMINER: ARANCIBIA, M.

SERIAL NO: 10/677,309

:

FILED: OCTOBER 3, 2003

: GROUP ART UNIT: 1763

FOR: METHOD OF RECLAIMING
SILICON WAFERS

RESPONSE AND REQUEST FOR RECONSIDERATION

OK
to
enter

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

MOT
11/03/2006
In response to the Office Action dated July 14, 2006, Applicants respectfully request reconsideration of the above-identified application in view of the following remarks:

Request for Reconsideration begins on page 2 of this paper.